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2823

Docket No.: M4065.0073/P073
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Donald L. Yates

Application No.: 09/123,430

Art Unit: 2823

Filed: July 28, 1998

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE
CONTAMINATION IN SEMICONDUCTOR
WET-PROCESSING VESSELS

AMENDMENT AFTER FINAL ACTION (37 C.F.R. § 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated January 30, 2004 (Paper No. 20040122), finally rejecting claims 1, 6, 7, 9, 10, 15, 22, 25, 44, 61-64, 66, and 67, please amend the above-identified U.S. patent application as follows:

Amendments to the Specification are shown beginning on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 5 of this paper.

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Remarks/Arguments begin on page 19 of this paper.